

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Masaru SASAKI, et al.

SERIAL NO: 10/591,343

GAU: 2813

FILED: August 31, 2006

EXAMINER: MALEK, MALIHEH

FOR: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE AND
PLASMA OXIDATION METHOD

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

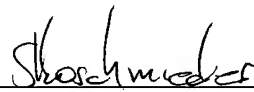
It is hereby requested that a **three** month extension of time be granted to April 22, 2009 for

- ☒ filing a response to the Official Action dated: October 22, 2008
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27.

The required fee of \$1,110.00 is being made by credit card payment online (if electronically filed), or is attached hereto (if paper filed), and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



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